

## 40 C.F.R. § 63.8990

## What parts of my plant does this subpart cover?

- (a) This subpart applies to each new, reconstructed, or existing affected source at an HCl production facility.
- (b) The affected source is the group of one or more HCl production facilities at a plant site that are subject to this subpart, and all associated wastewater operations, which contain the collection of emission streams listed in paragraphs (b)(1) through (5) of this section.

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